



IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

Inventor(s): Kizilyalli, et al

Case: 58-23-174

Serial No.: 09/882,367

Filing Date: June 15, 2001

Examiner: Maria F. Guerrero

Group Art Unit: 2822

Title: CMOS DEVICE FABRICATION UTILIZING SELECTIVE LASER ANNEAL TO
FORM RAISED SOURCE/DRAIN AREAS

ASSISTANT COMMISSIONER FOR PATENTS

Alexandria, VA 22313

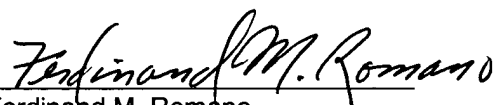
SIR:

CHANGE OF CORRESPONDENCE ADDRESS

In accordance with the Manual of Patent Examining Procedures, Section 601.03, please change the mailing address for all correspondence in the above-identified application to:

Agere Systems Inc.
4 Connell Drive, Room 4U-533C
Berkeley Heights, NJ 07922-2747 USA
(908) 508-8513 Fax: (908) 508-8326

Respectfully,


Ferdinand M. Romano
Reg. No. 32752
Phone 407-371-3250

Date:

28 August 2003

Agere Systems Inc.
4 Connell Drive, Room 4U-533C
Berkeley Heights, NJ 07922-2747 USA

2822

12/COA
12-10-03
A.Wall

RECEIVED
SEP - 4 2003
TECHNOLOGY CENTER 2800